

1 **Micro-electrical discharge machining of large aspect ratio blind micro-holes using a novel self-**
2 **flushing technique**

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4 Zhixiang Zou ^{1,2} · Zhijian Huang ² · Kangcheung Chan ³ · Taiman Yue ³ · Zhongning Guo ² · Jiangwen Liu

5 ^{2,*}

6 ¹ School of Mechatronic Engineering, Guangdong Polytechnic Normal University, Guangzhou,
7 Guangdong, 510665, PR China

8 ² State Key Laboratory of Precision Electronic Manufacturing Technology and Equipment, Guangdong
9 University of Technology, Guangzhou 510006, PR China

10 ³ State Key Laboratory of Ultra-precision Machining Technology, Department of Industrial and Systems
11 Engineering, The Hong Kong Polytechnic University, Hong Kong, China

12

13 *Corresponding author: Jiangwen Liu.

14 Email: fejwliu@scut.edu.cn

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16 **ABSTRACT**

17 Due to the debris accumulates in the central areas of the inter-electrode gap (IEG) and being difficult to
18 evacuate in the micro-electrical discharge machining (micro-EDM) process, achieving a large aspect
19 ratio (AR) for blind micro-holes remains a significant challenge. Based on our previous research on
20 debris secondary flow distribution theory in micro-EDM, we propose a novel self-flushing technique
21 using a center-slotted tool electrode to enhance debris evacuation in the central regions of the IEG. A
22 simulation model was developed to analyze the motion and distributions of debris under the self-flushing

23 technique operation. A simulation model was developed to analyze the motion and distribution of debris
24 under the operation of the self-flushing technique. The results indicated that a secondary flow effect
25 occurred within the IEG, concentrating most debris at the center. In comparison to the conventional solid
26 cylindrical tool approach, the debris evacuated through the central slot pathway with the self-flushing
27 effect. Experiments were undertaken to validate the model and the experimental results were well
28 matched with the simulation. Furthermore, the machining efficiency was improved by 73.1 % using the
29 self-flushing technique. The slot position and width of the slotted tool electrode and speed of rotation
30 was also shown an important contribution to the effectiveness of self-flushing. A blind micro-hole with
31 an impressive AR of 27.42 (corresponding to a depth of 5.41 mm and an entrance diameter of 197.3 μ
32 m) was successfully drilled. This represents the highest AR reported to date for Ti6Al4V alloy using
33 micro-EDM. This novel self-flushing technique is innovatively solved the challenge of difficulty in
34 exhausting debris that accumulated in the center IEG due to the secondary flow effect. It is concluded
35 that the novel self-flushing technique is highly transferrable to process a large AR blind micro-hole on
36 Ti6Al4V alloys.

37 Keyword: Micro-EDM; Large AR micro-hole; Secondary flow; Self-flushing technique; Center slotted
38 tool electrode

39

40 **1 Introduction**

41 In recent years, a larger AR (depth-to-diameter ratio) ≥ 5 micro-holes was growing in numerous
42 commercial applications [1]. Tiwary et al. [2] stated that the fabrication of large AR micro-holes as
43 among the most common operations in the manufacturing of many engineering parts. However, such
44 parts demand high strength-to-weight ratios as well as good corrosion resistance at extreme temperatures

45 and pressures, and thus they are frequently fabricated with materials such as Ti6Al4V alloys. In general,
46 the common methods of micro-hole manufacture include mechanical micro drilling, laser drilling, micro-
47 electrochemical machining (micro-ECM) and micro-EDM [3]. Routio et al. [4] reported that
48 conventional mechanical micro drilling was usually constrained by workpiece material properties such
49 as strength and hardness, etc. Nasrollahi et al. [5] stated that laser drilling resulted in holes with large
50 tapers and severe material splatter, as well as a limited achievable micro-hole AR. As for micro-ECM, it
51 has significant advantages for processing difficult-to-cut metal materials [6]. Chen et al. [7] stated that
52 the ECM was normally affected by the flow fields, electric fields, and chemical corrosion properties.
53 Consequently, the processing stability would be probably be affected [8]. Among these methods, the
54 micro-EDM can machine almost all conductive material regardless of the hardness and strength
55 properties of the workpiece materials [9-10]. Thus, micro-EDM is frequently employed to manufacture
56 micro-hole in the hard-to-process material [11].

57 However, in micro-EDM, the flushing of debris and bubbles from the IEG becomes challenging
58 when increasing the drilling depth of blind micro-holes. Consequently, frequent abnormal discharges and
59 short circuits occur, causing low machining efficiency and extensive tool electrode wear, especially
60 limiting the AR of blind micro-holes[12]. Wang et al. [13-14] proposed a three-dimensional flow field
61 model involving liquid, gas, and solid phases within the inter-electrode gap (IEG) during EDM drilling.
62 They reported that bubble expansion serves as the primary mechanism for expelling bubbles from the
63 machining gap. A significant amount of debris is carried out of the IEG along with the expanding bubbles.
64 However, this expelling effect weakens when the bubbles reach the side gap (i.e., the micro-hole wall),
65 where bubbles may even block the side gap. This blockage reduces or entirely stops the flow of working
66 fluid within the IEG, causing debris to accumulate in the bottom gap. Consequently, frequent short

67 circuits or arc discharges occur [15]. To overcome this issue, researchers focused on increasing the debris
68 and bubbles removal using various approaches, such as ultrasound assisted, tool electrode planetary
69 movement, flushing and shaped tool electrodes, etc. Zhao et al. [16] observed that ultrasonic vibration
70 assistance can improve the liquid flow behavior substantially, and hence decrease the debris gathering in
71 the IEG, leading to increasing the machining efficiency and the micro-hole AR size. In addition, Li et al.
72 [17] employed an ultrasonic circular round vibrating electrode to improve the circulating liquid medium
73 and debris removal in the IEG, resulting in an increased micro-hole machining performance. Despite the
74 fact that ultrasonic vibration assistance can improve the debris removal, this usually caused the micro-
75 EDM process to be unstable or even unattainable under the ultra-small energy conditions [18-19].
76 Furthermore, Bamberg et al. [20] offset the electrodes to a specific value for providing planetary motion.
77 In this manner, the debris is easily to remove from the IEG zone, resulting in increased flushing and
78 reduction of the tool electrode wear. Accordingly, Yu et al. [21] combined planetary motion and the
79 ultrasonic vibrations to produce an unevenly distribution gap for debris and/or gas bubble to exit from
80 the IEG, and as a consequence, both the processing efficiency and micro-hole AR size increased.

81 On the other hand, it should be noted that there is no useful self-flushing strategy besides the solid
82 tool rotation and bubble movement under the blind micro-hole processing in traditional micro-EDM [22].
83 In spite of the fact that the rotary tubular tool electrode can provide effective flushing and avoid the
84 debris accumulating in the IEG, residual is formed in the micro-hole bottom. More recently, Li et al. [23]
85 used the mist deionized water jet in drilling micro-holes, which lead to increasing the debris removal and
86 a deeper micro-hole was achieved. Nonetheless, developing the mist deionized water jet system and
87 controlling the mist flow rate is burdensome and an additional complication. Furthermore, as the
88 manufacturing tool electrode technique advanced, shaped tool electrodes (i.e. helical electrode, notch

89 electrode, incline slot electrode and inclined through-hole electrode) are widely used, and which play a
90 critically role in the prevention of debris accumulations in the IEG. Plaza et al. [24] applied helical-
91 shaped electrodes and micro-hole diameter of 661 μm , and an AR of 10 was drilled. Kumar et al. [10]
92 observed that the notch tool electrode offers a channel for the debris take can easily be cleaned away
93 from the IEG, and thus, a high machining efficiency with relatively low tool electrode wear rate was
94 achieved. Further, Kumar et al. [25] proposed a tool electrode with inclined micro-channels to help
95 remove debris from the IEG. In comparison to a solid cylindrical tool electrode, the AR value is increased
96 by 300%. Moreover, Kumar et al. [26] drilled the inclined through micro-holes into the solid tool and
97 found the debris and bubbles could exit from the micro slot through the hole. As a consequence, a large
98 AR micro-hole (i.e., AR of 12.25) was successfully fabricated. Nevertheless, it should be noted that these
99 structures of helical and incline a slot on the tool electrode surface were usually damaged due to the
100 inevitable tool electrode wear that occurred. As a result, the stable and continuous debris removal of such
101 shaped tool electrodes will not be maintained, which restricts the AR of micro-hole. Moreover,
102 fabrication of the inclined through hole on the tool electrode surface is usually restricted by the tool
103 diameter (e.g., drilling inclined micro-holes on tool electrodes with diameters of less than 200 μm is
104 challenging). In addition, according to Kumar et al. [27], when fabricating a large AR micro-hole, drilling
105 multiple pathway inclined holes into the solid cylindrical tool electrode is required and needs extra
106 attention. Consequently, although these shaped electrodes can provide a better debris removal capability,
107 it is challenging to manufacture shaped tool electrodes with large aspect ratios for processing blind micro-
108 holes (with diameters $< 200 \mu\text{m}$). As a result, further increasing the AR of blind micro-holes is still a big
109 challenge.

110 As discussed earlier, most of literature focuses on how to remove debris out from the IEG, while

111 only a few papers report how the debris is distributed in the IEG. Ichikawa et al. [18] found that debris
112 are hard to cleared out of the center region of the IEG. Ekmekci et al. [27] reported that the debris
113 accumulates in a conical formation at the micro-hole's bottom center region. That is to say, most of debris
114 is distributed in the center region of IEG under the tool rotation condition. Interestingly, this distribution
115 of debris is similar to the well-known Einstein's tea leaf paradox. i.e., secondary flow theory. Einstein
116 [28] discovered that when tea was stirred in a cup with chopsticks, the leaves gathered in the bottom
117 center of the cup. Since the pressure at the edge of the cup is larger than at the center of cup, producing
118 a secondary flow effect, the tea leaves are moving towards the center area. Most recently, in our previous
119 work, Zou et al. [29] reported for the first time that the debris accumulated in the central area of the IEG
120 under the secondary flow effect in the micro-EDM. In general, the discharge channel will produce a
121 greater pressure, disturbing the accumulation of debris in the IEG and/or causing the debris and bubbles
122 to escape from the side gap. However, Ekmekci et al. [27] reported, in the pulse-off time, the channel
123 pressure is drastically decreased, leading to the pressure at the edge of the micro-hole being larger than
124 in the central area. Consequently, this pressure difference forces previously discharged debris back into
125 the IEG's central area. Also, this changed pressure may further strengthen the secondary flow effect in
126 the pulse-off time. There is no doubt that the accumulation of debris in the central IEG and the difficulty
127 of removing is one of the main reasons for the frequent abnormal discharges, resulting in a reduction of
128 the AR.

129 Inspired by this, a new self-flushing technique (i.e., center slotted tool electrode) based on the
130 secondary flow theory is firstly proposed to improve the removal of the debris accumulating in the central
131 areas of IEG. Furthermore, a simulation model was conducted to analyze the motion and distributions of
132 debris in the IEG to understand its mechanisms. Experiments were also further performed to evaluate the

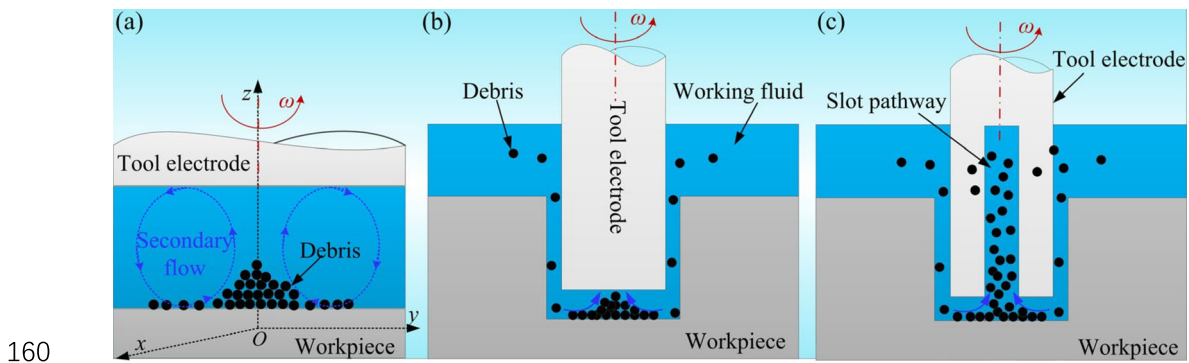
133 effectivity of this new self-flushing technique in increasing the AR of blind micro-holes using micro-
134 EDM.

135

136 **2 Method description of the novel self-flushing technique**

137 According to Einstein [28], tea leaves movement towards the center of the cup bottom owing to the
138 secondary flow effect (i.e., the tea paradox phenomenon). However, the rotation of the tool electrode
139 rotates the working fluid in the micro-EDM. Clearly, the motion and distribution of debris are quite
140 similar to the tea leaves (Fig. 1(a)). Furthermore, Fig. 1(b) indicates that the secondary flow effect forces
141 the debris to gather in the micro-hole bottom center [29]. As compared to solid cylindrical tool electrodes,
142 center slotted tool electrodes help to provide a self-flushing effect under the tool electrode rotation
143 condition. Also, the center slotted tool electrode (i.e., self-flushing electrode) provides a central slot
144 pathway for the debris evacuation. It is envisaged that the self-flushing electrode is not only able to
145 produce a self-flushing effect, but also removes debris from the IEG through central slot pathway (Fig.
146 1(c)). Furthermore, debris accumulation in the center of the IEG caused by the secondary flow effect
147 would be avoided. That is to say, the problem of debris accumulating in the center IEG and being difficult
148 to exhaust because of the secondary flow effect can be overcome. Consequently, the self-flushing effect
149 can enable sufficient de-ionization between IEG in the subsequent pulse-on time. On the other hand,
150 compared to the helical and inclined slot on the tool surface, since the debris removal pathway is inside
151 the center slotted tool, the center slotted pathway is minimally worn (Fig. 1(c)). Accordingly, combining
152 the action of the secondary flow effect, this proposed tool electrode can provide a stable and continuous
153 debris exhaust in the micro-EDM. However, it should be noted that the inefficient debris evacuation
154 causes a severe arcing and short circuits in the IEG, resulted in an increasing in tool electrode wear,

155 lowing machining efficiency, especially limiting the AR of micro-holes [12]. As a result, the proposed
 156 self-flushing tool electrode has a better potential for processing large AR blind micro-hole than that of
 157 the conventional solid cylindrical tool. To further understand the self-flushing technique, more detailed
 158 theoretical and experimental investigations will be examined and the results are presented in the
 159 subsequent sections.



160
 161 **Fig. 1. (a)** Schematic of secondary flow under the IEG. The evacuation of debris **(b)** under the solid
 162 cylindrical, and **(c)** under the center slotted tool electrode with novel self-flushing effect.

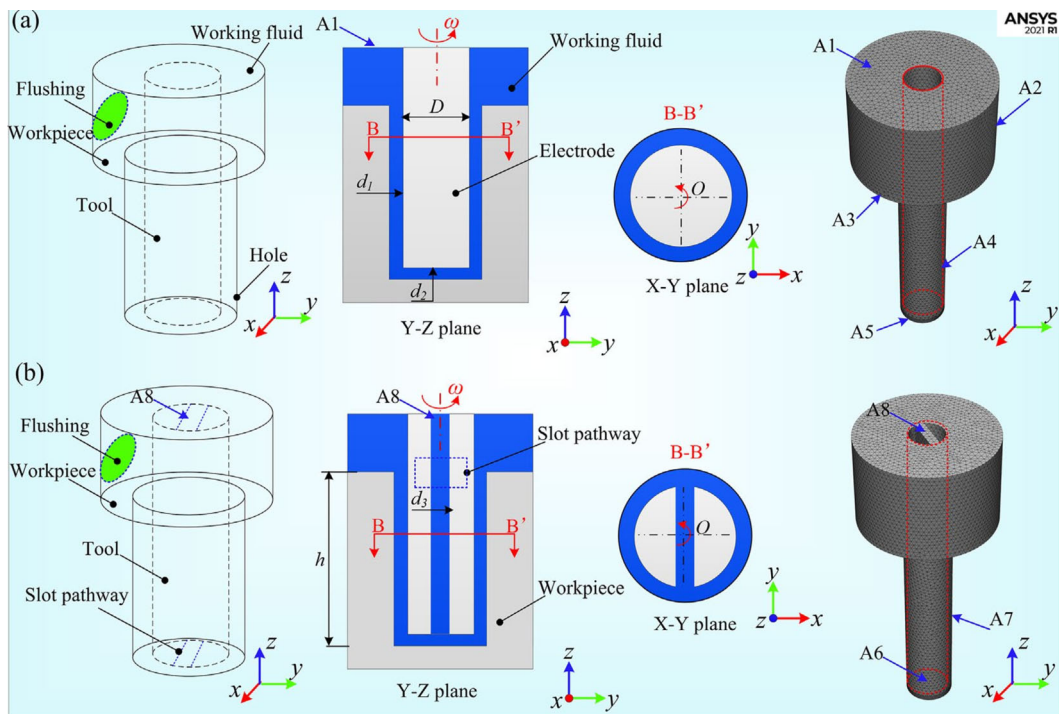
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164 3 Theoretical analyses of novel self-flushing technique

165 3.1 Model development

166 As discussed earlier, Li et al. [22] stated that there is no effective self-flushing approach except the
 167 bubble movement and tool rotation in the conventional blind hole drilling of EDM with a solid tool.
 168 Moreover, without additional flushing effect, a part of the bubbles is blocked in the hole wall, which
 169 affects the debris removal [13]. On the other hand, despite the flushing effect produced by the tool
 170 rotation, bubbles and debris can be removed from the side wall gap. However, it should be noted that
 171 when no additional flushing effect, resulting in a part of the debris accumulating in the IEG center and
 172 being very difficult to remove [18,27]. Due to the debris is always conductive as a byproduct of metal
 173 materials, thus the accumulation of debris in the central IEG and the difficulty of removing is one of the

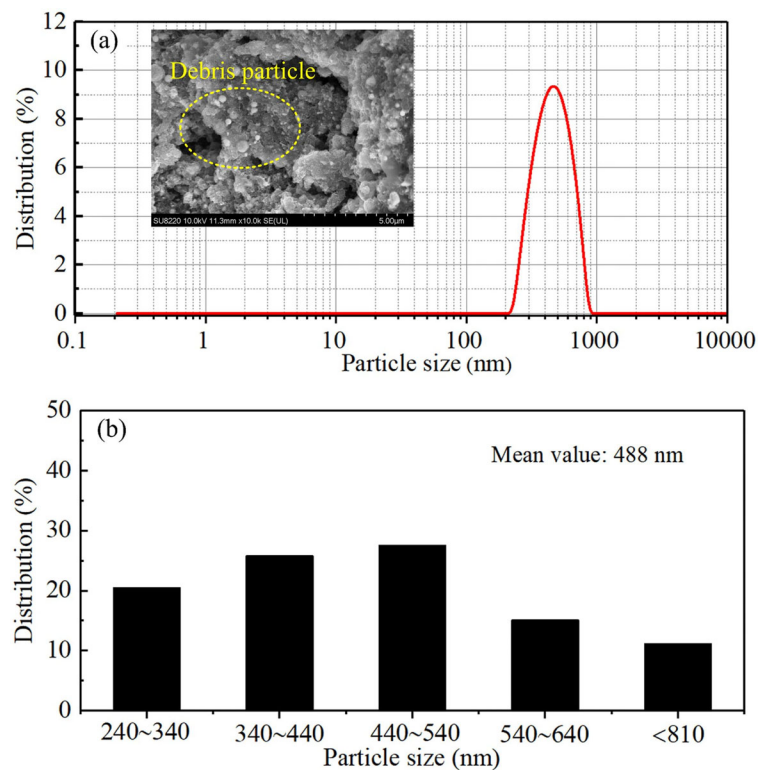
174 main reasons for the frequent abnormal discharges, leading to a poor machining performance [15]. Thus,
 175 a model was developed for analyzing the potential of the proposed novel self-flushing technique to solve
 176 the debris accumulation in the IEG center difficult to be removed. Since the EDM process is complex
 177 and bubbles have a significant effect on debris removal, the debris and bubbles observed at the hole exit
 178 using a high-speed camera in conjunction with the simulation results are further investigated in the
 179 subsequent experimental validation. As a consequence, the model was simplified and analyzed the
 180 movement and distribution of debris in the IEG. Other assumptions are: (1) no influence of bubbles
 181 generation and the fluid is incompressible, (2) tool electrode wear and workpiece materials removal are
 182 not considered, and (3) debris are from the workpiece material (Ti6Al4V), and debris are initially evenly
 183 and static distributed in the IEG. Fig. 2 shows the geometry established in the 3D model in ANSYS
 184 FLUENT. It consists of the working liquid (kerosene), the tool electrode (tungsten), and the workpiece
 185 (Ti6Al4V).



186
 187 **Fig. 2.** 3D geometric model for micro-hole processing using (a) solid cylindrical tool electrode, and (b)

188 center slotted tool electrode.

189 Mastud et al. [30] stated the debris shape produced by the micro-EDM is spherical and the size is
190 normally less than 1 μm . Thus, prior to the simulation process, the debris particles were collected and
191 analyzed. SEM was applied to observe the debris particles and the its size distribution was measured
192 using a particle size analyzer. It is can be observed from Fig. 3, the debris are spherical, with an average
193 size of 488 nm. Accordingly, the debris particles are a spherical, with a diameter of 500 nm, in the
194 simulation process. Since this work investigated the debris and flow field in blind micro-holes with large
195 AR, thus the depth of the micro-holes was set to be 1000 μm and the inlet diameter to be 190 μm in the
196 numerical modeling. Furthermore, Table 1 listed the simulation parameter values and boundaries in the
197 simulation.



198

199

Fig. 3. The size distribution of debris particle.

200

201

Table 1. Parameters and boundaries for the simulation model.

Item	Value	Unit
Tool electrode diameter (D)	150	μm
Spindle speed	500	rpm
Side gap / d_1	20	μm
Machining gap / d_2	20	μm
Slot width / d_3	40	μm
Flushing port diameter	2	mm
Flushing velocity	2	m/s
Condition of boundaries	Condition of boundaries	Value
Outlet	A1, A8	P=0 Pa
Workpiece-fluid interface	A3	No slip
Wall	A2, A5, A7	No slip
Tool electrode-fluid interface	A4, A6	n=500 rpm

203 The equations for conservation of momentum and mass for the working liquid are given:

$$204 \quad \rho \frac{\partial u}{\partial t} + \rho(u \cdot \nabla)u = \nabla \cdot \left[-PI + \mu \left(\nabla u + (\nabla u)^T \right) \right] + F \quad (1)$$

$$205 \quad \frac{\partial \rho}{\partial t} + \nabla \cdot (\rho u) = 0 \quad (2)$$

206 where u is a working liquid speed, ρ is a working liquid density, μ is a working liquid dynamical
 207 viscosity, p is a working liquid pressure, T is an absolutely temperature (K), F is the volume forces (N),
 208 and I is the identification matrices. Moreover, debris particles tracking formulates the problem using
 209 Lagrange's equation and then solves it taking Newton's second law of movement. Thus, the secondary
 210 motion equation is used to calculate the location of the debris particles:

$$211 \quad \frac{dq}{dt} = v \quad (3)$$

$$212 \quad \frac{d}{dt}(m_p v) = F_t \quad (4)$$

213 where the q is the location of debris particles, v is the velocity of debris particles, and m_p is the mass

214 of debris particles. F_t is the total force of debris particles, and thus the fluid drag force F_D is the working
 215 liquid forces on the debris surface and calculated by:

$$216 \quad F_D = \frac{1}{\tau_p} m_p (u - v) \quad (5)$$

217 where τ_p is a responding time of the particles, and u is the fluid velocity. The graviton force on the
 218 debris particles in solution is assumed to be:

$$219 \quad F_g = m_p g \frac{(\rho_p - \rho_z)}{\rho_p} \quad (6)$$

220 where ρ_p is the particles density, ρ_z is the fluid density, and g is gravitational acceleration vector.

221 Note that, when there is a differential speed of the liquid surrounding the debris particle, the Saffman
 222 forces $F_{saffman}$ can be written as:

$$223 \quad F_{saffman} = 1.61 d_p^2 (\rho \mu)^{\frac{1}{2}} (u - v) \left| \frac{\partial u}{\partial l} \right|^{\frac{1}{2}} \quad (7)$$

224 where d_p is the diameter of the debris particle, $\partial u / \partial l$ is the fluid velocity gradient. When there is a
 225 pressure difference in the fluid around the debris particles. Thus, the pressure gradient F_p can be
 226 expressed as:

$$227 \quad F_p = -\frac{\pi d_p^2}{6} \frac{\partial p}{\partial l} \quad (8)$$

228 where $\partial p / \partial l$ is the fluid pressure gradient. Thus, equation of motion of a particle in the fluid can be
 229 expressed as:

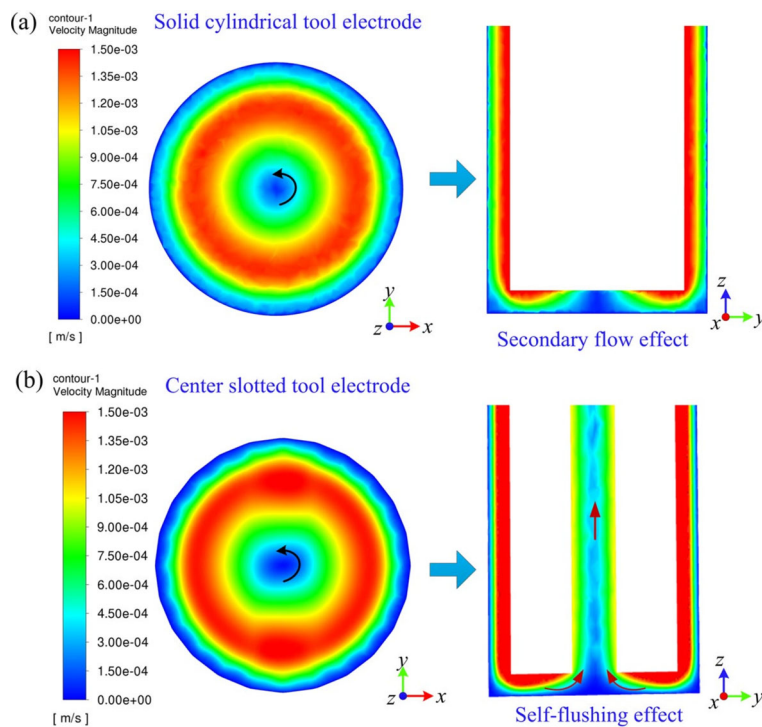
$$230 \quad \frac{d}{dt} (m_p v) = F_D + F_g + F_{saff} + F_p \quad (9)$$

231

232 3.2 The distribution characteristic of flow and pressure field distribution

233 Fig. 4 compares the flow field distribution in the different tool electrodes. It can be observed that a
 234 high-flow field velocity area (red) is formed at the edge of the IEG, and a low-flow velocity area (blue)

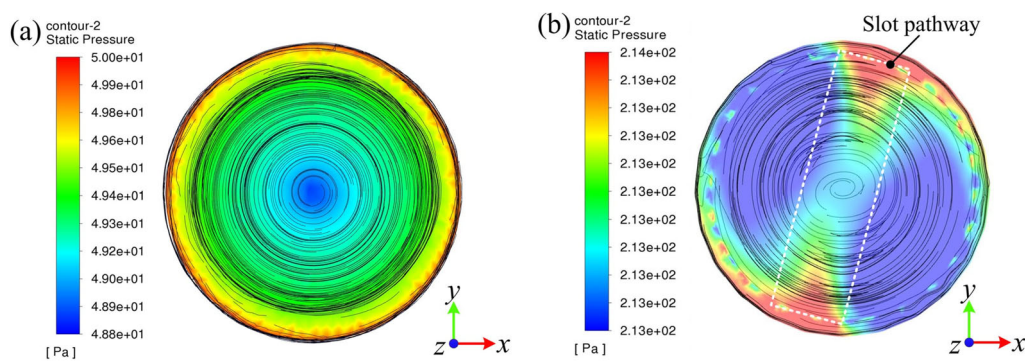
235 is formed at the center of the IEG (Fig. 4(a)). Obviously, it indicates that the velocity of the fluid field
 236 increased gradually as distance from the micro-hole bottom center, which is very consistent with the
 237 well-known tea leaf paradox (secondary flow effect). It should be noted that there is a zero-flow field
 238 velocity at the workpiece wall due to this surface being a no-slip boundary. On the other hand, in the IEG
 239 (YZ plane), the ingress of clean fluid is through the side gaps, and the egress of the contaminated fluid is
 240 through the central slot pathway of the center slotted tool electrode (i.e., self-flushing effect) (Fig. 4(b)),
 241 which has significant difference with that of solid cylindrical electrode (Fig. 4(a)). Based on the
 242 secondary fluid effect, a self-flushing effect is formed in the center slotted tool electrode. Its primary
 243 function is to remove debris particles from the center area of the IEG and simultaneously introduce fresh
 244 working fluid into the IEG. This also means that a continuous circulation of working fluid is developed
 245 in the IEG. Thus, it is envisaged that the transport of debris through such central slot pathway would be
 246 of benefit in minimizing abnormal discharges in the IEG.



247

248 **Fig. 4.** The flow field distribution in (a) the solid cylindrical, and (b) the center slotted tool electrode.

249 Fig. 5 illustrates the pressure distributions superimposed with debris traces for the different tool
250 electrodes. Both debris traces indicate that debris migrates from the bottom edge of the hole toward its
251 central areas. This can be explained as follows: although the structure of the center-slotted electrode
252 differs significantly from the conventional cylindrical electrode, the secondary flow effect still develops.
253 During the discharge process (i.e., pulse-on time), high temperature and pressure are generated in the
254 IEG, effectively removing debris from the gap. However, during the pulse-off time, the discharge channel
255 pressure decreases sharply, causing the pressure at the hole's edge to become greater than that in the
256 central area. This pressure difference forces the debris back into the central region of the IEG, as also
257 reported by Ekmekci et al. [27]. This combined effect of pressure change and secondary flow leads to
258 the dynamic accumulation of debris in the central area, making it difficult to evacuate. Consequently,
259 with the solid cylindrical tool electrode (Fig. 5(a)), debris tends to accumulate in the central region,
260 resulting in frequent abnormal discharges. In contrast, the proposed center-slotted pathway serves as a
261 pressure relief port during both pulse-on and pulse-off times, facilitating the effective removal of debris
262 from the IEG.



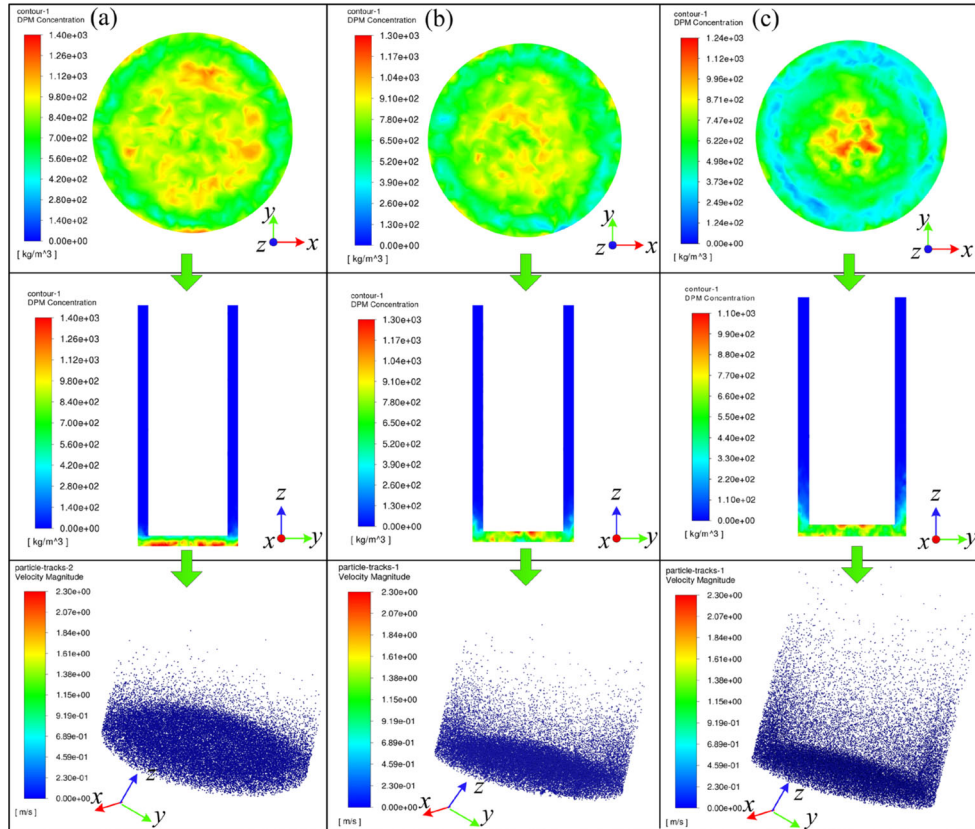
264 **Fig. 5.** The pressure distributions superimposed with debris traces: (a) the solid cylindrical tool, and (b) the
265 center slotted tool.

266

267

268 **3.3 The distribution and movement characteristic of debris particles**

269 To further investigate the relationship between the center-slotted tool and the debris distribution in
270 the IEG, the results from 0.5 s to 1.5 s were analyzed to study the distribution and movement of debris
271 particles. As observed, with the solid cylindrical tool, at 0.5 s, most of the debris is concentrated at the
272 bottom of the IEG, while a small portion moves upward through the side gap (Fig. 6(a)). At later stages,
273 the majority of the debris migrates toward the central area of the IEG, where it accumulates (Figs. 6(b)
274 and 6(c)). As previously discussed, the discharge channel generates high pressure during the pulse-on
275 time, which drives the debris to exit the IEG through the side gap. However, during the pulse-off time,
276 the channel pressure decreases drastically, causing the pressure at the hole's edge to become greater than
277 that at the center. According to Ekmekci et al. [27], this pressure change forces the previously discharged
278 debris to return to the central region of the IEG. Similarly, Ichikawa et al. [18] reported that debris is
279 difficult to clear from the central region of the IEG. Moreover, the secondary flow effect tends to
280 accumulate debris particles in the central area of the IEG. It is hypothesized that the accumulation of
281 debris in this central area increases the frequency of unusual discharges, which ultimately limits the
282 achievable AR.

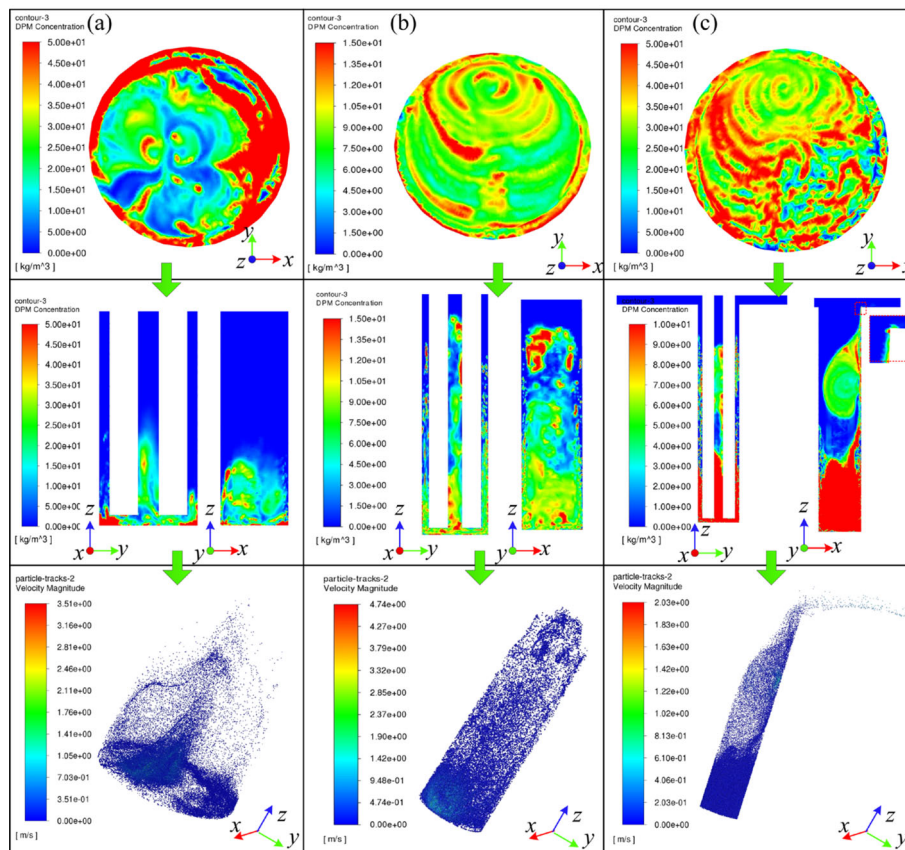


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284 **Fig. 6.** The debris distribution in the solid cylindrical tool electrode with different times: **(a)** 0.5 s, **(b)** 1
 285 s, and **(c)** 1.5 s.

286 In contrast, with the center-slotted tool electrode, the debris particles are relatively evenly
 287 distributed at the bottom of the IEG (Fig. 7). At 0.5 s, most debris particles begin to move upward through
 288 the central slot pathway (Fig. 7(a)). As time increases to 1 s, some debris also migrates through the side
 289 gaps, though the velocity and quantity of debris particles are significantly greater in the central slot
 290 pathway compared to the side gaps (Fig. 7(b)). By 1.5 s, it is evident that the debris moves toward the
 291 micro-hole outlet through the central slot pathway (Fig. 7(c)). However, with the solid cylindrical tool
 292 electrode, at 1.5 s, a significant amount of debris remains trapped within the IEG (Fig. 6(c)). Additionally,
 293 the pressure gradient in the center-slotted tool electrode is notably higher (Fig. 5). As expressed by Eqs.
 294 (8)–(9), compared to the solid cylindrical tool, debris is removed from the IEG more rapidly with the
 295 center-slotted tool electrode (Figs. 6 and 7). Furthermore, as shown in Fig. 7(c), the debris is more

296 uniformly distributed at the bottom of the IEG, with a lower concentration than that observed under the
 297 cylindrical electrode condition. This indicates that most of the debris has either been evacuated or is
 298 actively being removed through the central slot pathway. Additionally, the center slot helps mitigate
 299 debris accumulation in the central gap caused by the secondary flow effect. This further demonstrates that
 300 the proposed self-flushing technique effectively utilizes the secondary flow effect to overcome debris
 301 evacuation challenges in deep-hole machining. It is anticipated that the center-slotted tool electrode can
 302 significantly enhance debris removal from the IEG, thereby offering the potential to process large aspect
 303 ratio (AR) micro-holes. To verify the simulation model, detailed experiments were conducted, and the
 304 results are reported in the following section.



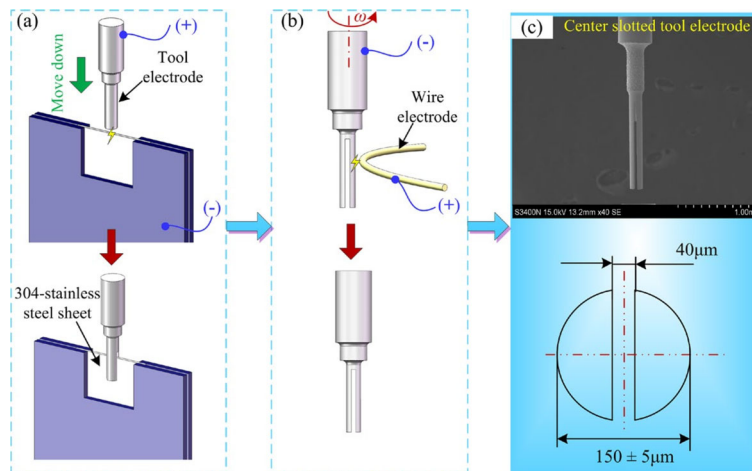
305
 306 **Fig. 7.** The debris distribution in the center slotted tool electrode with different times: **(a)** 0.5 s, **(b)** 1 s,
 307 and **(c)** 1.5 s.

308

309 **4 Experimental procedures**

310 **4.1 Materials**

311 For all experimentation, they were conducted on the micro-electrical discharge machine (SX-
312 200hpm, Sarix). In this study, the workpiece material was a titanium alloy (Ti6Al4V) with dimensions
313 of 70×40×10 mm, the tool electrode material was a tungsten carbide (WC) rod and working liquid
314 medium was hydrocarbon oil. Furthermore, the schematic of the center slotted tool electrode fabrication
315 process is shown in Fig. 8. It can be seen that a 304-stainless steel sheet (i.e., its dimensions for length,
316 height and thickness are 60 mm, 30 mm and 20 μm.) was fixed on the machine table and used to micro-
317 EDM slot the solid tool. In the tool fabrication process, the voltage was 100 V, the peak current 2.31
318 A, the frequency 10 kHz, the pulse width 20 μs, and the spindle speed 0 rpm, respectively. The working
319 medium was hydrocarbon oil, while 304-stainless steel sheet as the negative, and the tool electrode as
320 the positive. After the feed was completed, the tool electrode was slotted, and the WEDG module was
321 then used to process the center slotted tool electrode to the required diameter (Fig. 8(b)). Furthermore,
322 the fabrication of shaped tool electrodes with diameters less than 200 μm is also relatively little challenge
323 compared to other shaped tool electrodes.



324
325 **Fig. 8.** Diagram of the slotted tool electrode fabrication: (a) slotted process, (b) electrode gridding by

326 WEDG, and (c) actual center slotted tool electrode.

327

328 4.2 Methodology

329 The main purpose of this investigation is focused on using the new self-flushing technique to
330 increase the debris removal in the IEG central areas and understand its exhaustion mechanisms,
331 subsequently enabling a large AR blind micro-hole to be processed. The present study compares the
332 machining performance (i.e., machining efficiency, tool electrode wear and machining depth) of the
333 center slotted tool electrode with the solid cylindrical electrode. Furthermore, the effects of slot position
334 and width of the slotted tool electrode, pulse parameters, and rotation speed on machining performance
335 were also studied. Each experiment repeated 5 times, and the detailed conditions were listed in Table 2.
336 Finally, fabricating a micro-hole with a large AR using this new self-flushing technique further
337 demonstrates the feasibility for increasing the micro-EDM performance.

338 **Table 2.** Processing conditions for the experiment investigation.

Parameters	Value
Voltage (V)	90, 100, 110, 120, 130
Frequency (kHz)	100
Pulse width (μ s)	1, 2.5, 4, 5.5, 7
Rotation speed (rpm)	100, 200, 300, 400, 500
Peak current (A)	1.36
Tool electrode diameter (μ m)	150
Slotted width (μ m)	30, 40, 50

339 The workpiece was cleaned with an ethanol solution for 5 minutes both prior to and after the micro
340 EDM drilling. After washing, the specimens are drying and then tested. To examine the cross-sectional
341 appearance, the micro-holes were cut along the cross-section by wire-EDM process. Furthermore,

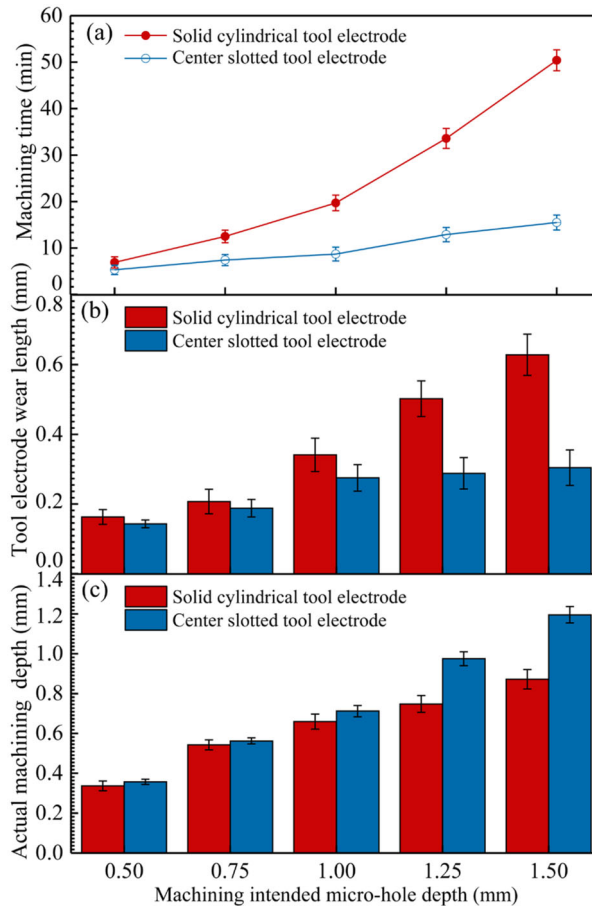
342 microscopic structures were analyzed and observed using SEM and EDS. A similar observation process
343 was also performed for the tool electrodes.

344

345 **5 Results and discussion**

346 **5.1 Comparison of the solid cylindrical and center slotted tool electrode**

347 In general, the frequent abnormal discharges due to the bubble and debris accumulation leads to a
348 decrease in the drilling feed rate, increase in tool wear, and limits the drilling depth [31]. To highlight the
349 advantages of the center slotted tool electrode with regard to machining efficiency, tool electrode wear
350 and depth of machining, a comparison study has been carried out. Micro-holes were fabricated with
351 different tool electrodes, the micro-hole depth is 0.5, 0.75, 1, 1.25, 1.5 mm. The voltage was 110 V, the
352 peak current 1.36 A, the frequency 100 kHz, the pulse width 4 μ s, the spindle speed 500 rpm, and the
353 slot width 40 μ m. Fig. 9(a) shows that both tool electrodes had an increase in machining time with the
354 intended micro-hole depth. However, machining time for the center slotted tool electrode was less than
355 the solid cylindrical tool electrode. In particular, after machining a depth for 1 mm, there is a significant
356 difference in machining time. For instance, when machining an intended micro-hole depth of 1.5 mm,
357 the machining time for the slotted tool electrode is only about 15.5 min, while the solid cylindrical tool
358 requires more than 50.4 min. That is to say, the center slotted tool electrode has a much better machining
359 efficiency than the solid cylindrical tool electrode.



360

361 **Fig. 9.** The effect of the different tool electrode: **(a)** machining time, **(b)** tool electrode wear, and **(c)**

362 actual machining depth.

363 Fig. 9(b) shows that the tool electrode wear of the center slot tool electrode is less than the solid

364 cylindrical tool electrode. This change becomes more apparent with increasing micro-hole depth. For

365 instance, when the intended micro-hole depth is 1.5 mm, the tool electrode wear length of the solid

366 cylindrical tool electrode is 0.628 mm, whereas the center slotted tool electrode is only 0.304 mm. The

367 larger tool electrode wear length means that more severe the tool electrode wear occurred. As discussed

368 earlier, the insufficient debris removal frequently leads to unusual discharges and short circuits in the

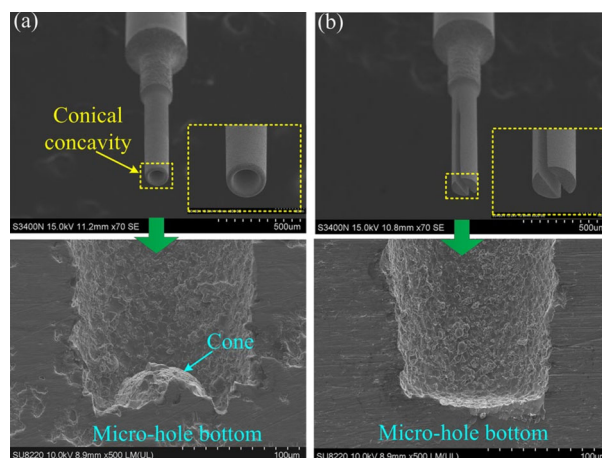
369 micro-EDM. Consequently, this results in increasing the tool electrode wear [12]. This demonstrate that

370 the self-flushing electrode has a greater capacity for debris removal than in the conventional solid

371 cylindrical tool electrode. It also can be seen from Fig. 9(c), that the actual machining micro-hole depth

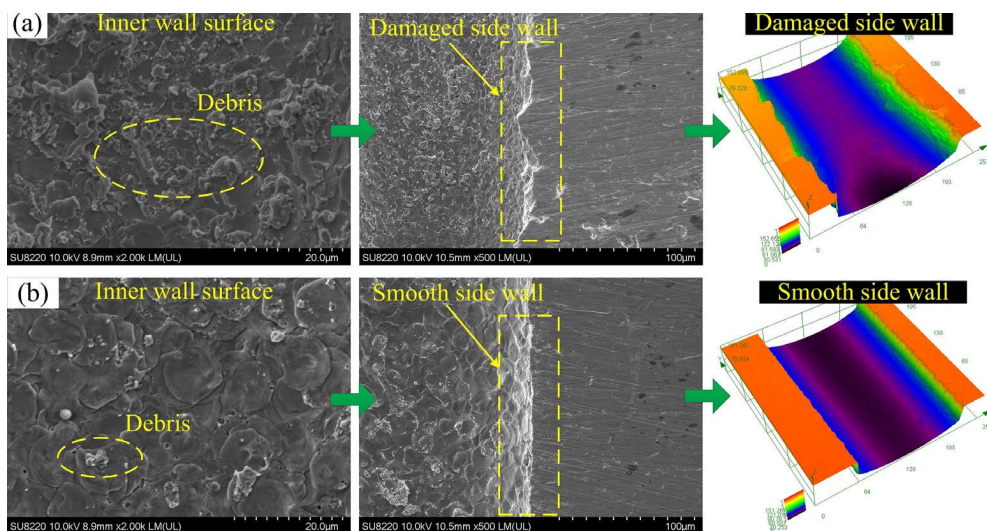
372 of center slotted tool electrode is larger than in the solid cylindrical tool electrode. For instance, when
373 the intended depth is 1.5 mm, the actual machining micro-hole depth of center slotted tool electrode is
374 about 1.195 mm, while the solid cylindrical tool electrode is only about 0.872 mm. It indicates that the
375 center slotted tool electrode has the potential for increasing the AR of blind micro-holes under similar
376 experimental conditions.

377 Fig. 10 shows the SEM pictures of the tool tip and hole section views. A visible cone is form in the
378 central hole bottom and the tool tip is wear to form a cone-shaped concavity in the solid cylindrical tool
379 (Fig. 10(a)). In comparison, a micro-hole without the cone and tool electrode tip without conical
380 concavity was processed by using the center slotted tool electrode (Fig. 10(b)). This importance is
381 because that the debris accumulates in a cone formation at the hole bottom central area [27]. On the other
382 hand, such debris is hard to evacuate from the center region of IEG [18]. Thus, the discharge material
383 removed interactions between the debris particles and the tool continued. As a result, a cone is formed
384 and its complementary conic-concave emerges on the tool tip. It is envisaged that the self-flushing
385 electrode can effectively remove the debris out from the IEG through the central slot pathway, eliminating
386 the accumulated debris near the center of the IEG.



387
388 **Fig. 10.** The effect of different tool electrodes on micro-hole and tool electrode tip geometries: **(a)** solid
389 cylindrical, and **(b)** center slotted tool electrode.

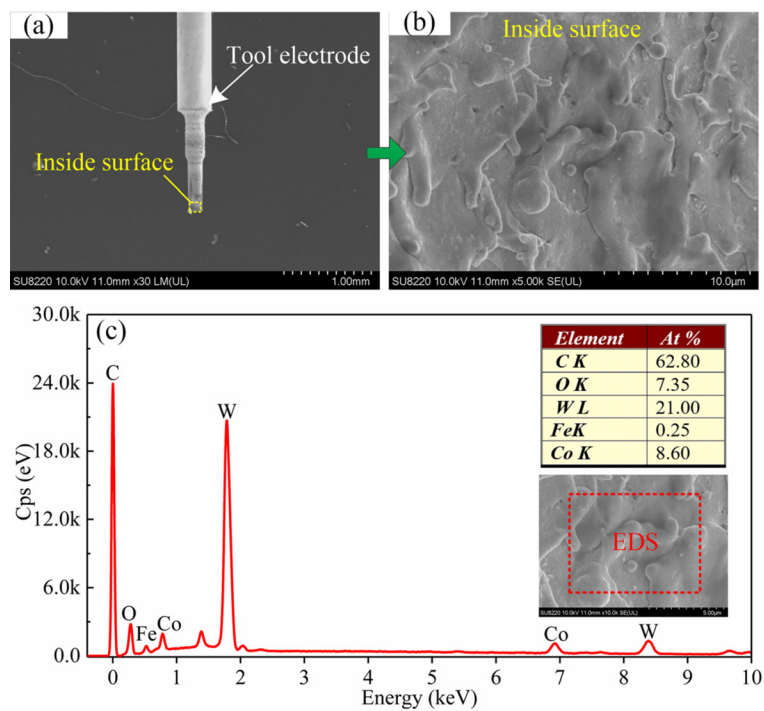
390 To further determine that the new self-flushing technique could effectively exhaust the debris from
 391 the IEG through the central slot pathway, Fig. 11 compares the SEM of the holes inner wall. As compared
 392 with the solid cylindrical electrode, only a small amount of debris is attached to the inner walls in the
 393 center slotted tool electrode (Fig. 11). These images reveal that the center slotted tool electrode has a
 394 better inner wall quality than that of the solid cylindrical tool electrode. It is also observed from Fig. 11
 395 that more severe micro-hole side wall damage occurs in the solid cylindrical tool electrode than in the
 396 self-flushing electrode. It is well known that the debris particles are only removed through the side gap
 397 in the solid cylindrical tool electrode. There is no effective self-flushing effect using a solid cylindrical
 398 tool electrode [22]. Furthermore, since the side gap is too small, debris is frequently stuck in the side gap,
 399 and this evident from Fig. 11(a). As a result, the ineffective debris removal produces the excessive arcing
 400 and/or short circuiting in the side gap. In contrast, most of the debris can be removed through the central
 401 slot pathway of the self-flushing electrode, and hence less debris adhered to the inner wall of the micro-
 402 holes.



403
 404 **Fig. 11.** The effect of different tool electrode on inner wall and profile of micro-hole: (a) solid cylindrical
 405 tool electrode, and (b) center slotted tool electrode.

406 Furthermore, the inner wall surface of the center channel has been investigated with SEM and EDS

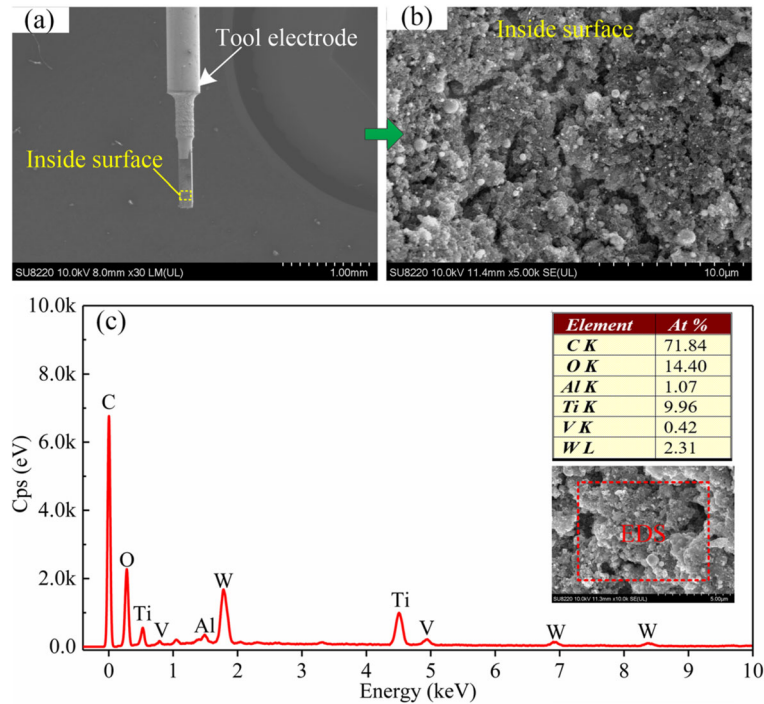
407 analyses. Figs. 12a-b indicates the SEM images of the original inside surface of center slotted tool
 408 electrode. As can be seen, the inside wall of the original tool electrode has obvious electrical discharge
 409 melting micro-craters and re-melted material. Moreover, Fig. 12(c) indicates the EDS spectrum of the
 410 original tool inside wall. The C, O, W, Fe, and Co contents are approximately 62.8 At%, 7.35 At%, 21
 411 At%, 0.25 At% and 8.6 At%, respectively. In comparison, Figs. 13a-b show the SEM pictures of the
 412 inside surface of the self-flushing tool electrode after drilling. There is a large number of debris particles
 413 on the inner wall surface of the center slot electrode (Fig. 13(b)). To further identify the debris material,
 414 inner wall surface of the center slot electrode was also examined by EDS analysis. In Fig. 13(c), the
 415 constituents of the Ti6Al4V workpiece material (Ti, Al, and V elements) can be observed on the inside
 416 wall of the center slot electrode. This experimental result confirms that the debris is removed through the
 417 central slot pathway of the center slotted tool electrode, which was very consistent with the simulation
 418 results.



419

420 **Fig. 12. (a)** The SEM of original slotted tool electrode, **(b)** SEM images of the slotted tool electrode

421 inside surface, and (c) EDS analysis.



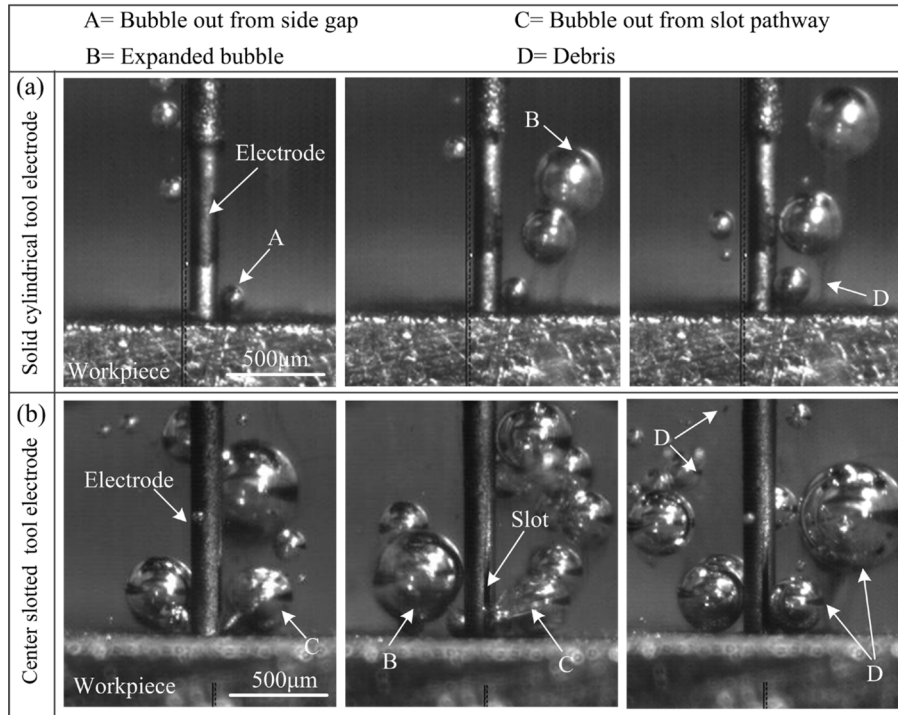
422

423 **Fig. 13. (a)** SEM of the center slotted tool electrode after machining, **(b)** SEM images of the slotted tool

424 electrode inside surface, and **(c)** EDS analysis.

425 However, the IEG has a large number of bubbles and have a significant impact on debris removal
426 in practical EDM drilling. Thus, to fully understand the self-flushing technique, a high-speed camera was
427 applied to further studied the mechanism for the debris removal. As shown in Fig. 14(a), it can be
428 observed that a small amount of bubbles exhaust from the side gap in the solid cylindrical tool electrode.
429 Among the bubble expansion is the main cause of bubble movement and follows the debris removal from
430 the IEG [13]. In general, a greater number evacuation of bubbles means the better the debris exhaustion
431 efficiency [26]. However, due to the expansion of the bubbles, the size of the bubbles grows, resulting in
432 a higher resistance to the bubbles movement. Thus, the debris is easier to re-solidify on the inner wall of
433 micro-holes (Fig. 11(a)). The increased hole depth increases the difficulty of bubble evacuation, because
434 the bubbles generated in the IEG have to resist greater pressure from the working liquid [32]. This is the
435 reason why fewer and fewer bubbles escape from the micro hole (Fig. 14(a)). Moreover, without

436 additional flushing effect, a part of the bubbles is blocked in the hole wall, which affects the debris
437 removal [13]. Thus, frequent abnormal discharges and short circuits occur in the conventional EDM
438 drilling, resulting in a low EDM drilling performance (Fig. 9). In comparison, Fig. 14(b) shows that a
439 large number of bubbles remove from the slot pathway of the center slotted tool electrode. That is to say
440 that the center slotted tool electrode has a better debris evacuation efficiency than that of the solid
441 cylindrical tool electrode. Since the self-flushing effect is formed in the IEG by using the center slotted
442 electrode rotating. Although the bubble expansion and working liquid pressure caused resistance to its
443 movement in the case of center slotted tool electrode, this proposed self-flushing technique can provide
444 a driving flushing force to the bubbles. As a result, the working liquid is continuously flowing into the
445 IEG by self-flushing technique, thus both debris and bubbles are efficiently removed from the IEG,
446 causing an increase in EDM drilling performance. These results further proved that the debris can exhaust
447 from the slot pathway of the center slotted tool electrode, and the center slotted tool electrode has a better
448 debris evacuation efficiency than in the solid cylindrical tool electrode. These experimental results are
449 very well agreed with the simulation results.



450

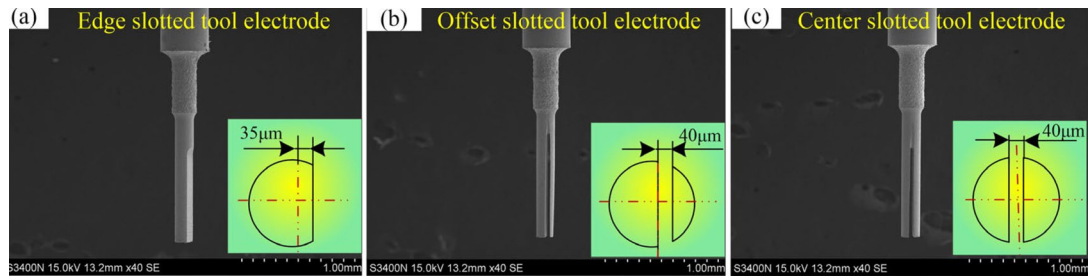
451 **Fig. 14.** High-speed photographs of the dynamic characteristics of bubbles in (a) solid cylindrical tool
 452 electrode, and (b) center slotted tool electrode.

453

454 5.2 Effect of slot position of the self-flushing electrode

455 As discussed earlier, the debris can effectively exit from the slot pathway of the center slotted tool
 456 electrode by using self-flushing effect. Furthermore, the slot position of slotted tool electrode also has a
 457 critical effect on the secondary fluid action. Thus, the slot position and width should be discussed. Fig.15
 458 shows the different slot positions, such as edge, center, and offset slot. In this section, a voltage of 100
 459 V, peak current 1.36 A, frequency of 100 kHz, pulse width of 4 μ s, spindle speed of 500 rpm, and slot
 460 width of 40 μ m were applied. Whilst the intended micro-hole depths were 1, 1.5, 2, 2.5, 3 mm.

461



462

463 **Fig. 15.** The different slot position of slotted tool electrode: **(a)** edge, **(b)** offset, and **(c)** center.

464 As can be seen, both tool electrodes show an increase in machining time with micro-hole depth.

465 However, the machining time for the offset slotted tool electrode is less than that of the center slot but

466 larger than the edge slotted tool electrode under various intended micro-hole depths. For instance, when

467 the intended micro-hole depth is 3 mm, the machining time of center slotted tool electrode is 34.5 min,

468 the offset slotted tool electrode is 41.4 min and the edge slotted tool electrode is 45.5 min (Fig. 16(a)).

469 Apparently, the center slotted tool electrode has higher machining efficiency than those of other

470 electrodes (i.e. edge and offset tool electrode). Furthermore, the tool electrode wear length of the offset

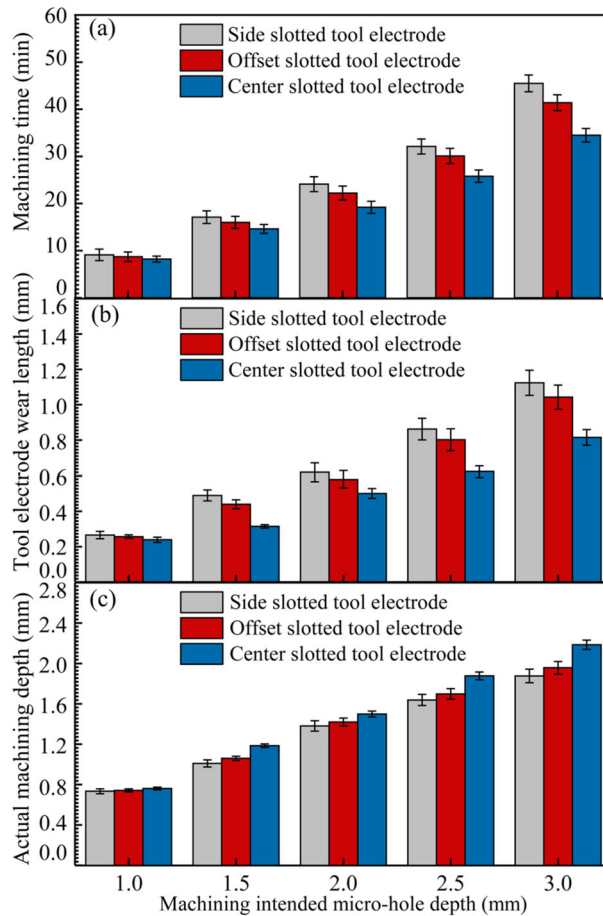
471 slotted tool electrode is less than for the center slot but larger than the edge slotted tool electrode under

472 various intended micro-hole depths (Fig. 16(b)). Similarly, the actual machining depth has the same trend,

473 as shown in Fig. 16(c). For example, when the intended micro-hole depth is 3 mm, the actual machining

474 depth of the center slotted tool electrode is 2.185 mm, the offset slotted electrode is 1.957 mm and the

475 edge slotted electrode is 1.876 mm.

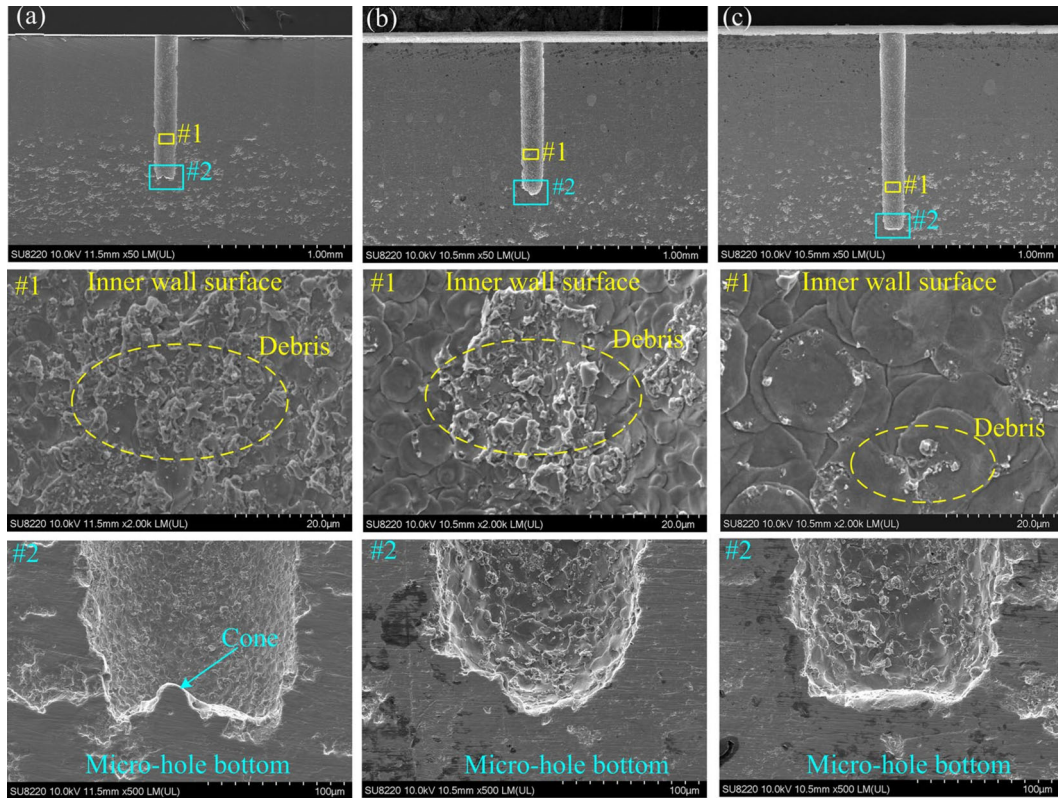


476

477 **Fig. 16.** The effect of the different slot positions of the slotted tool electrode: (a) machining time, (b) tool
 478 electrode wear, and (c) actual machining depth.

479 Fig. 17 indicates the SEM pictures of the section views of the micro-holes drilled with various slot
 480 position on the tool electrode. The debris accumulates at the micro-hole inside wall with different slot
 481 position of tool electrode conditions, however, especially for the edge slotted tool electrode, more debris
 482 accumulates gathered at the micro-hole inside wall (Fig. 17(a)). Although the edge slotted tool electrode
 483 has sufficient space to remove most of the debris from the side gaps, debris movement through the side
 484 gap, or accumulating with the micro-hole depth increases. Fig. 17(a) shows a magnified image of the
 485 micro-hole inside wall. Much debris accumulates at the inside surface of the micro-hole. As can be seen
 486 from Fig. 17(a), there is a slight cone in the central micro-hole bottom (Fig. 17(a)). That is to say, the
 487 debris is hard to be removed from the center region of IEG in the case of edge slotted tool electrode. In

488 contrast, in the offset slotted tool electrode, the debris gathering in the holes inside surface is still severe
489 (Fig. 17(b)). But in case of the center slotted tool electrode, little debris accumulates at the inner wall.
490 These indicated that most of the debris can be exhausted from the center slot pathway and a micro-hole
491 without cone is obtained (Fig. 17(c)). It can be concluded that the self-flushing tool electrode has a better
492 drilling performance. The number of debris adhering to the hole inner wall is less in the case of center
493 slotted tool electrode. In contrast, in the case of offset and edge slot positions, a large amount of debris
494 adheres to the hole inner wall. This indicated that most of the debris can be exhausted from the center
495 slot pathway, whereas a considerable amount of debris accumulates in the hole sidewalls in the case of
496 the edge and offset slot electrodes. These may result in the formation of secondary spark discharges
497 within the sidewall gap, resulting in discharge craters with different shapes and sizes. Furthermore, there
498 may be a certain influence of the different slot positions on the size and shape of the discharge crater in
499 the inner wall of the hole. As shown in Fig. 17, in the center slot position condition, the discharge crater
500 size of the hole inner wall is larger than that of the edge and offset positions.



501

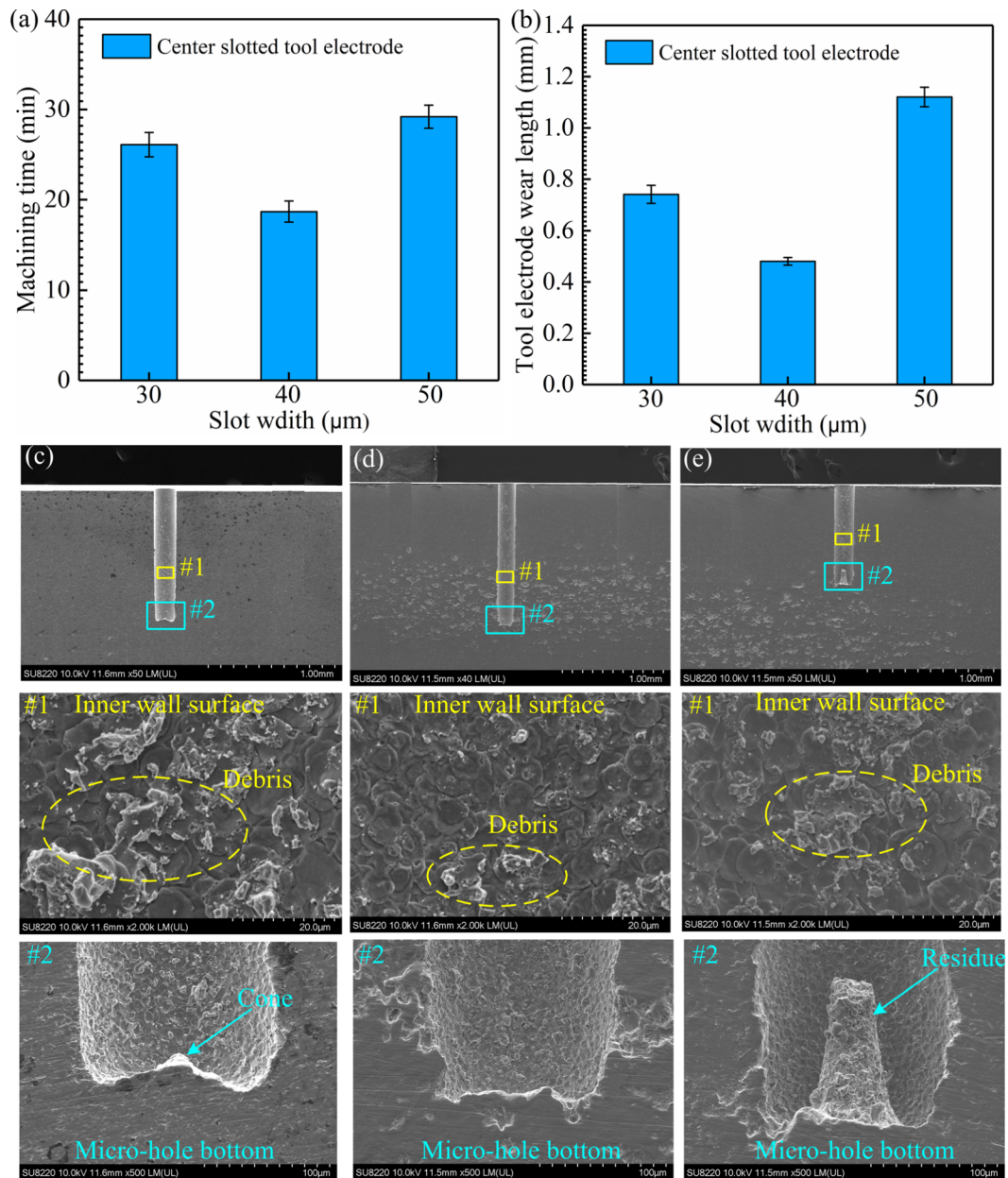
502 **Fig. 17.** SEM images of the section views of micro-holes under different slot positions of tool electrode
 503 conditions: **(a)** edge, **(b)** offset, and **(c)** center.

504

505 **5.3 Effect of slot width of the self-flushing electrode**

506 It should be noted that the slot width is also expected to have a critical effect on the machining
 507 performance. As a consequence, a comparative experiment was undertaken to study the effect of the slot
 508 width on the processing time, tool electrode wear and machining depth. In this study, a voltage of 100 V,
 509 peak current 1.36 A, frequency of 100 kHz, pulse width of 4 μ s, spindle speed of 500 rpm, and an intended
 510 micro-hole depth is 2 mm were the reconditions. Whereas the slot width of the center slotted tool
 511 electrode was 30, 40 and 50 μ m. As the slot width increasing, the machining time first decreased and
 512 then increased (Fig. 18(a-b)). Furthermore, as the slot width increased, the tool electrode wear length
 513 also decreased first and then increased. Although the secondary flow effect can allow the debris to exit

514 through the center slot pathway, the debris cannot be effectively removed due to the slot width being too
515 small (i.e., 30 μm). As a result, a cone is forming at the bottom of the hole (Fig. 18(c)). Nevertheless, on
516 further increasing the slot width, there was sufficient space remove most of the debris, but when the slot
517 width was 50 μm , residue accumulated at the central area of the hole bottom (Fig. 18(d)). In comparison,
518 a micro-hole bottom without a cone was avoided for a center slot width of 40 μm (Fig. 18(e)). As noticed,
519 when the slot widths were 30 μm and 50 μm , a cone and/or residue are formed at the central area of the
520 hole bottom. Furthermore, which resulting in a serious tool electrode wear, significantly decreasing the
521 drilling depth of the micro-hole. For instance, the machining depths for slot widths 30, 40 and 50 μm
522 were 1.01 mm, 1.40 mm and 0.77 mm, respectively. Thus, the center slotted tool electrodes with a slot
523 width of 40 μm are preferred for fabricating micro-holes with a high AR.



524

525 **Fig. 18.** The effect of slot width of tool electrode on (a) machining time, (b) tool electrode wear, and (c-

526 e) SEM images of the section views of micro-holes with slot width is 30, 40, 50, respectively.

527

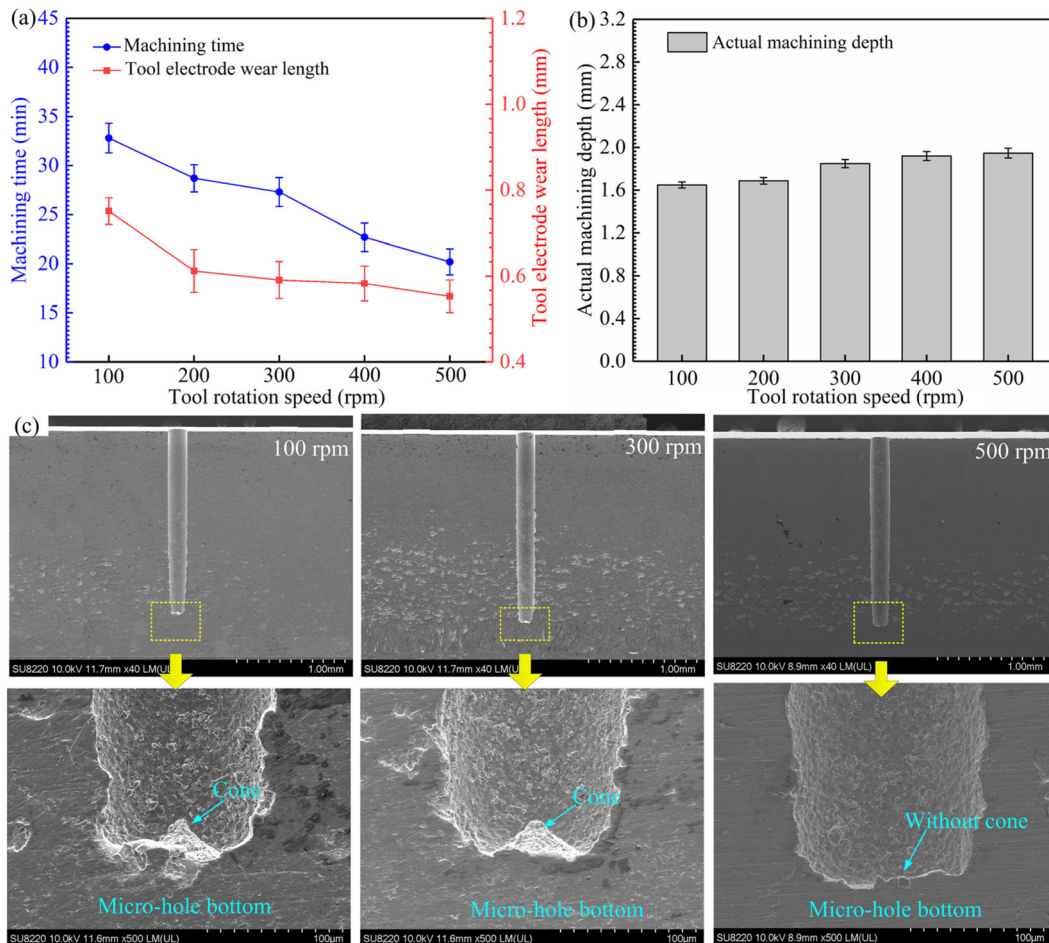
528 5.4. Effect of the tool electrode rotation speed

529 As discussed earlier, the tool electrode rotational speed also plays a critical role in the secondary

530 fluid and self-flushing effect, however, the current micro-EDM machine (SX-200hpm, Sarix) has varying

531 spindle in the range 0–500 rpm. Thus, the effect of various tool rotation velocity (i.e. 100, 200, 300, 400

532 and 500 rpm) on the machining performance was investigated as reported in this section. Voltage of 110
 533 V, peak current of 1.36 A, frequency of 100 kHz, pulse width of 4 μ s, and the intended micro-hole depth
 534 of 2 mm were fixed. Fig. 19 shows that, as the increase of tool rotation velocity from 100 rpm to 500
 535 rpm, the machining time and tool electrode wear length decreased from 32.8 min to 20.2 min, and 0.764
 536 mm to 0.553 mm, respectively. Whereas the machining micro-hole depth increased from 1.649 mm to
 537 1.946 mm. Although the center slotted tool electrode provided a large slot pathway for debris removal,
 538 the secondary flow effect was insufficient to efficiently remove debris under the low tool rotation speed
 539 condition (i.e. 100 rpm).



540
 541 **Fig. 19.** The effect of tool electrode rotation speed on (a) machining time and tool electrode wear, (b)
 542 actual machining depth, and (c) the SEM images of the section views of micro-holes with various rotation
 543 speed.

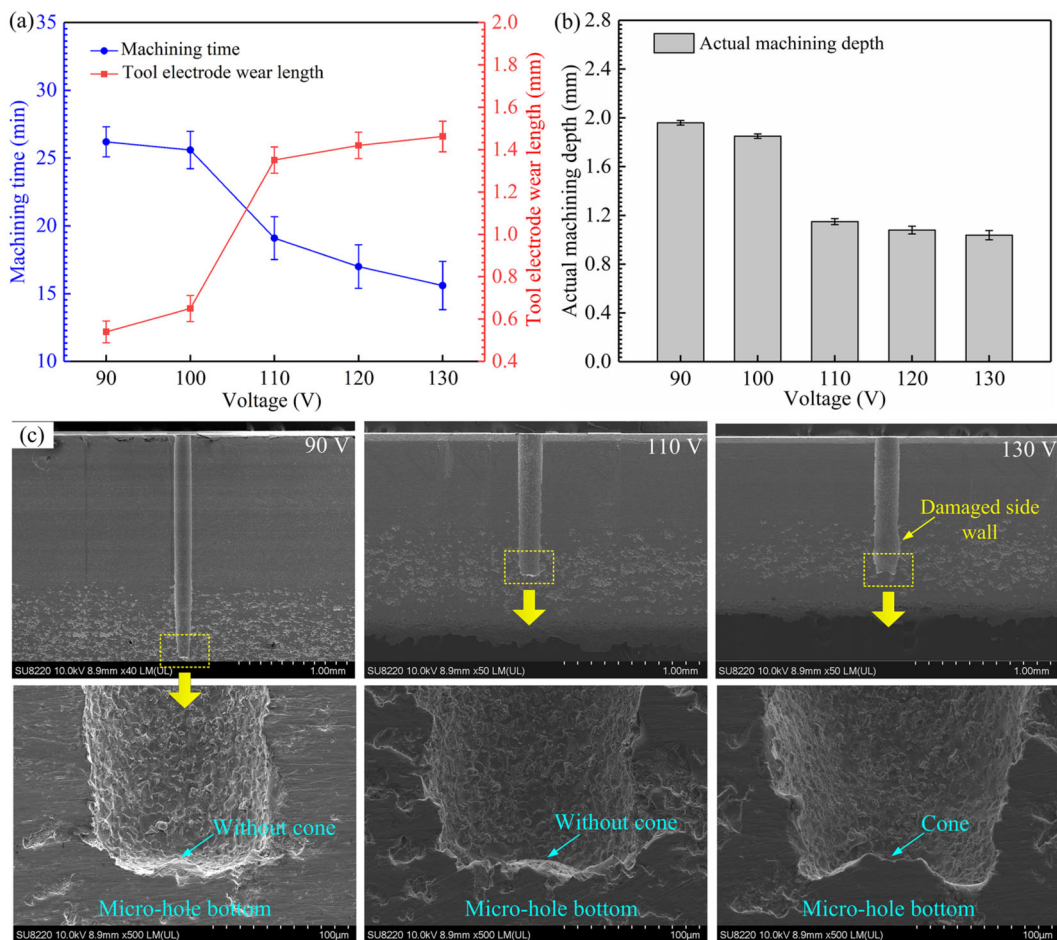
544 However, it should be noted that the pressure difference (i.e., secondary flow effect) is proportional
545 to the tool rotation speed, which means that the higher the tool rotation speed, the larger the secondary
546 flow action. Apparently, further increased tool electrode rotation speed, resulting in an increasing debris
547 exhaustion through the center slot pathway. Fig. 19(c) shows that when the rotation velocity is 100 rpm,
548 the micro-hole bottom formed a cone. That is to say, the debris particles were hard to be evacuated from
549 the center area of IEG with a low rotation speed, resulting in a forming a cone in the central area of
550 micro-hole bottom [18]. In contrast, further increasing the rotation speed, the secondary flow effect, i.e.,
551 self-flushing effect is also increased, significantly improving the debris exhaustion. Thus, as the rotation
552 speed increase, the cone of micro-hole bottom from to nearly flat (Fig. 19(c)). This is indicated that the
553 rotation speed of 500 rpm was preferred for this process.

554

555 **5.5 Effect of the pulse parameters**

556 The pulse parameters (i.e., voltage and pulse width) also play a critical effect on the micro-EDM
557 process. Thus, the effect of pulse voltage and pulse width on the machining process will be investigated.
558 In this investigation, the remaining parameters were set: the pulse frequency of 100 kHz, peak current of
559 1.36 A, the slot width of 40 μm , the rotation speed of 500 rpm and the intended micro-hole depth of 2
560 mm. Furthermore, the pulse width and pulse frequency were maintained at 4 μs and 100 kHz, respectively.
561 Micro-holes were fabricated with pulse voltage of 90, 100, 110, 120 and 130 V are shown in Fig. 20.
562 When the pulse voltage increased from 90 V to 130 V, the processing time reduced from 26.2 min to 15.6
563 min, the tool electrode wear increased 0.543 to 1.462 mm, while the actual machining micro-hole depth
564 reduced from 1.963 mm to 1.038 mm. In general, a greater the voltage, the higher the electrical melt and
565 evaporative activity, and the better the machining efficiency. Nonetheless, the high pulse voltage

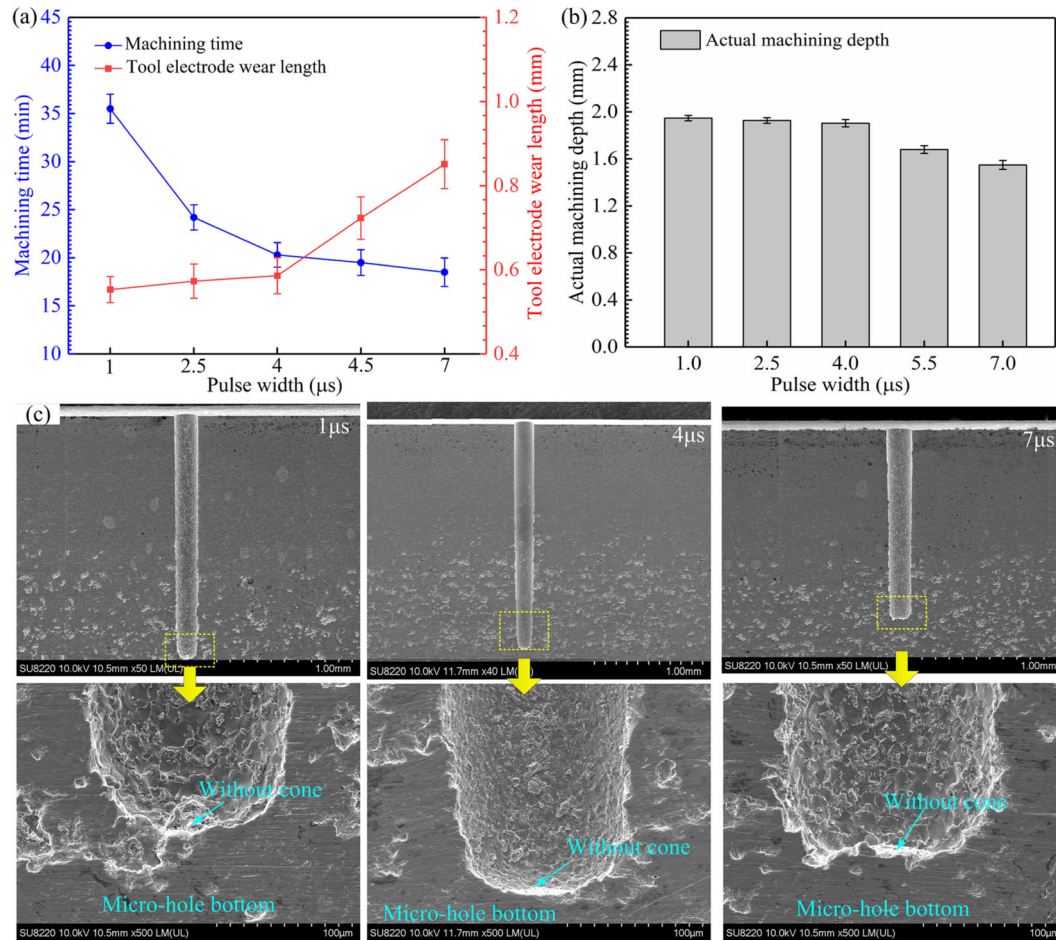
566 condition causes severe tool electrode wear, resulting in a decrease in the AR size. Furthermore, when
 567 using a low pulse voltage, the micro-holes had a good shape accuracy (Fig. 20(c)). However, further
 568 increase the pulse voltage led to damaging the side wall and a cone formed. Although low tool wear and
 569 better processing accuracy were found at the 90 V, fabrication of high AR micro-holes with a relatively
 570 high machining efficiency is the main target. Consequently, pulse voltage of 100 V is suitable for the
 571 self-flushing process.



572
 573 **Fig. 20.** The effect of pulse voltage on (a) machining time and tool electrode wear, (b) actual machining
 574 depth, and (c) the SEM images of the section views of micro-holes under various pulse voltage.

575 The effect of voltage is similar to that of pulse width, because larger voltages and/or pulse widths
 576 generate larger electrothermal energies inputs. Fig. 21 indicates the processing time, tool electrode wear
 577 length and actual machining depth of the micro-hole, while Fig. 21(c) compares the effect of pulse width

578 on the section views of the hole when processing at different pulse widths of 1, 2.5, 4, 5.5 and 7 μs . The
579 frequency and pulse voltage were set at 100 kHz, and 100 V, respectively. It can be observed, with the
580 pulse width increased from 1 μs to 7 μs , the machining time decreased from 35.5 min to 18.3 min, the tool
581 electrode wear increased from 0.551 mm to 0.863 mm, while the actual machining micro-hole depth
582 decreased from 1.945 mm to 1.554 mm. As shown in Fig. 21, a lower pulse width (i.e., 1 μs and 4 μs) has
583 a larger machining depth compared to a higher pulse width (i.e., 7 μs). As discussed earlier, the self-
584 flushing effect ensures sufficient de-ionization of the IEG during the subsequent pulse-on time, as most
585 of the debris is effectively removed during the pulse-off time. However, it is important to note that with
586 large pulse widths, the available pulse-off time for debris removal is reduced, which can limit the
587 effectiveness of the self-flushing effect. In general, inefficient debris removal often leads to severe arcing
588 and short circuits, resulting in increased tool electrode wear and a limitation in the achievable AR.
589 Nevertheless, under large pulse conditions (e.g., 7 μs), there was no significant cone formation at the
590 bottom of the micro-holes (Fig. 21(c)). This observation indicates that the self-flushing effect, generated
591 at a tool electrode rotation speed of 500 rpm, successfully prevents debris from accumulating at the
592 bottom of the hole. Consequently, a rotation speed of 500 rpm, a pulse voltage of 100 V, and a pulse
593 width of 4 μs are identified as optimal parameters for fabricating large aspect ratio micro-holes with
594 relatively high drilling efficiency.



595

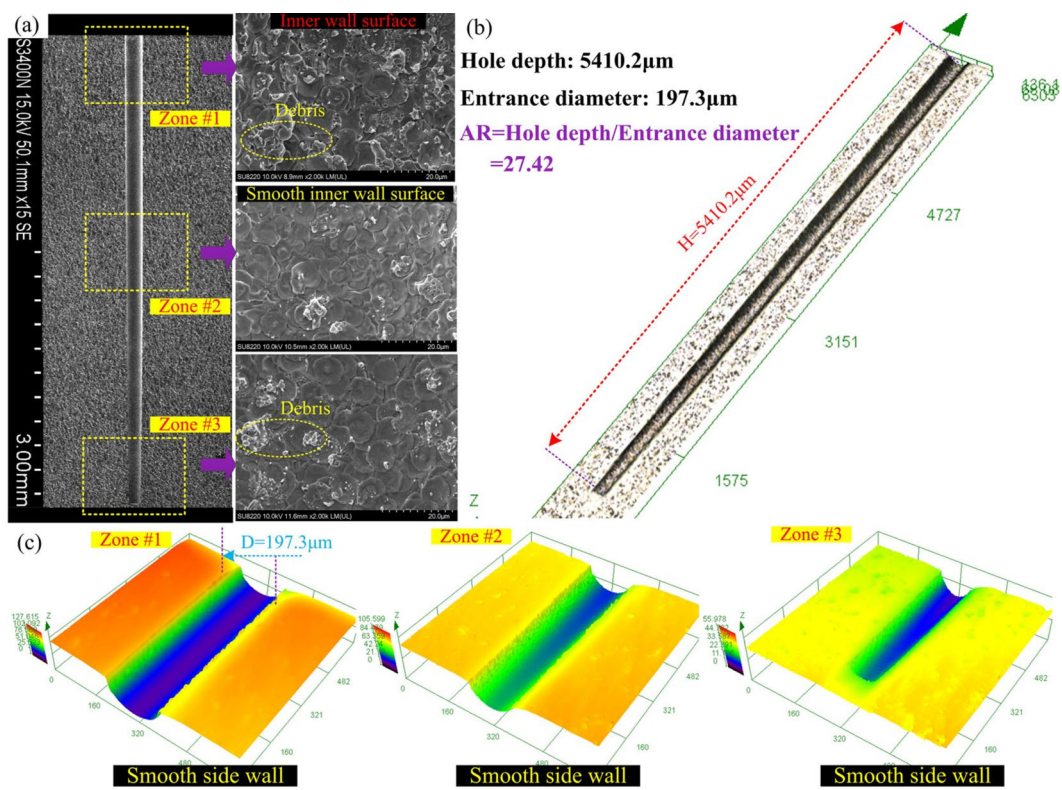
596 **Fig. 21.** The effect of pulse width on (a) machining time and tool electrode wear, (b) actual machining
 597 depth, and (c) the SEM images of the section views of micro-holes under various pulse widths.

598

599 6. Fabrication of micro-holes with a large AR

600 Based on above-mentioned experimental investigations, a large AR micro-hole was fabricated using
 601 the proposed self-flushing electrode with optimal parameters (i.e., pulse voltage of 100 V, peak current
 602 of 1.36 A, pulse frequency of 100 kHz, pulse width of 4 μs , rotation speed of 500 rpm, slot width of 40
 603 μm). The fabrication time for the center slotted electrode is approximately 140 min for the length of the
 604 slot of 8 mm and average electrode diameter of 150 μm . Fig. 22 shows the image of the drilled blind
 605 micro-hole, in which the depth of the micro-hole is approximately 5.41 mm, and the entrance micro-hole
 606 diameter is about 197.3 μm . That is to say, a micro-hole with an AR of 27.42 was fabricated in Ti6Al4V

607 by the proposed self-flushing electrode. The processing time of drilling process is approximately 80 min,
 608 and the wear length of the electrode is 2.231 mm. It should be noted that Table 3 are also listed the results
 609 of micro-EDM in the present and existing studies on large AR micro-holes on Ti6Al4V alloys. Apparently,
 610 this is the highest AR reported so far in the literatures for Ti6Al4V alloy by micro-EDM. Furthermore,
 611 the holes inner/side wall surface are smoother and a relatively small amount of debris adhered to the
 612 inside wall (Figs. 22(a) and (c)). This further indicate that most of the debris exited through the central
 613 slot pathway of the self-flushing electrode, which is consistent well with the simulation result. Thus, it
 614 indicated that the proposed self-flushing electrode is a simple and effective method for drilling a large
 615 AR blind micro-hole.



616
 617 **Fig. 22.** (a) The SEM of the cross-section of the large AR micro-holes, (b) and (c) the 3D morphology
 618 of the cross-section of the large AR micro-holes.

619
 620

621 **Table 3.** Comparison of the results of the present study with the existing literatures on micro-EDM of
 622 large AR blind micro-holes on Ti6Al4V alloys.

Authors	Workpiece materials	Depth of micro-hole (mm)	Micro-hole/tool dia. (μm)	Aspect ratio (AR)
Zhao et al. [16]	Titanium (Ti6Al4 V alloy)	3.2	200 (tool)	15
Plaza et al. [24]		6.81	661 (micro-hole)	10
Kumar et al. [25]		4.2	800 (tool)	7.5
Kumar et al. [26]		9.8	800 (tool)	12.25
Singh et al. [33]		10	574 (micro-hole)	17.42
Current investigation		5.41	197.3 (micro-hole)	27.42

623

624 7. Conclusions

625 This study proposed a novel self-flushing technique (i.e., center slotted tool electrode) to improve
 626 the debris removal in the IEG, fabricating a large AR blind micro-hole and with a good machining
 627 performance. From the combined analysis of simulations and experiments, the main conclusions below
 628 are drawn:

629 (1) Both the experiment and observation results were well supported the mechanism proposed for
 630 the debris removal. Using the center slotted tool electrode, the debris accumulated in the center IEG was
 631 effectively removed through the central slot pathway by the self-flushing effect.

632 (2) Compared to the solid cylindrical tool electrode, the processing performance is significantly
 633 improved with the center slotted tool electrode. The machining efficiency was increased about 73.1 %,
 634 and tool electrode wear was decreased about 62.5%.

635 (3) The slot position and width of the center slotted tool electrode and tool rotation speed play a
 636 critical role in the machining performances. The center slot, with a slot width of 40 μm is suitable for the

637 self-flushing effect. Further increasing the tool rotation speed, the self-flushing effect is increases
638 accordingly.

639 (4) By employing the optimal parameters, a micro-hole with a high AR of 27.42 (i.e., a depth of
640 5.41 mm, and entrance micro-hole diameter of 197.3 μm) was fabricated using the proposed self-flushing
641 technique, which is the highest AR reported so far in the literature for Ti6Al4V alloy using micro-EDM
642 drilling.

643 (5) The bubble expansion and working liquid pressure create resistance to bubble movement.
644 However, the proposed self-flushing technique generates a driving flushing force that facilitates the
645 movement of bubbles. As a result, the working liquid continuously flows into the IEG, enabling the
646 efficient removal of both debris and bubbles from the gap. This significantly enhances the EDM drilling
647 performance. In conclusion, the self-flushing technique demonstrates excellent potential and high
648 transferability for processing large AR blind micro-holes.

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650 **CRedit authorship contribution statement**

651 **Zhixiang Zou:** Conceptualization, Methodology, Writing–original draft, Writing–review & editing.

652 **Zhijian Huang:** Investigation, Measurement. **Kangcheung Chan:** Formal analysis, Writing–review &
653 editing. **Taiman Yue:** Formal analysis. **Zhongning Guo:** Conceptualization, Methodology, Supervision,

654 Resources. **Jiangwen Liu:** Supervision, Resources.

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656 **Declaration of competing interest**

657 The authors declare that they have no known competing financial interests or personal relationships that
658 could have appeared to influence the work reported in this paper.

659 **Acknowledgments**

660 The work described in this study was supported by the National Natural Science Foundation of China
661 [Grant Nos. 52175387 and 52075104]. This work was also supported by the Natural Science Foundation
662 of Guangdong Province, China [Grant No. 2024A1515011129], National Natural Science Foundation of
663 China [Grant No. U22A2062] and Major research and development projects of Jiangxi Province [Grant
664 No. 20223AAE02008].

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769 **Biography**

770 **Zhixiang Zou** is an Associate Professor in School of Mechatronic Engineering, Guangdong Polytechnic
771 Normal University. He received his Ph.D. in the State Key Laboratory of Precision Electronic
772 Manufacturing Technology and Equipment of Guangdong University of Technology. He was a research
773 assistant at the Department of Industrial and Systems Engineering of The Hong Kong Polytechnic
774 University. His research focuses on advanced manufacturing technology and green precision engineering.



775
776

777 **Zhijian Huang** is a Master's candidate in Electromechanical Engineering, Guangdong University of
778 Technology. His research focuses on the non-traditional machining.



779
780

781 **Kangcheung Chan** is Chair Professor of Manufacturing Engineering, Head of the Department of
782 Industrial and Systems Engineering and Associate Director of Research Institute for Advanced
783 Manufacturing of The Hong Kong of Hong Kong Polytechnic University. His research areas include
784 Advanced Manufacturing Technology, and Materials Engineering and Processing.



785

786

787 **Taiman Yue** was a professor in the Department of Industrial and Systems Engineering of the Hong Kong
788 Polytechnic University. He received his Ph.D. from the University of Southampton (UK). His research
789 focuses on advanced manufacturing technology and advanced engineering materials. He is a chartered
790 engineer.



791

792

793

794 **Zhongning Guo** is a Professor in school of electromechanical engineering at Guangdong University of
795 Technology. He received his Ph.D. in industrial and systems engineering department from the Hong Kong
796 Polytechnic University. His research focuses on micro machining and non-traditional machining.



797

798

799 **Jiangwen Liu** is a Professor in the State Key Laboratory of Precision Electronic Manufacturing
800 Technology and Equipment of Guangdong University of Technology. He received his Ph.D. in the

801 Department of Industrial and Systems Engineering from the Hong Kong Polytechnic University. His

802 research areas include Advanced Manufacturing Technology and Surface Engineering.



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